

**Amendments to the Specification**

Please amend the paragraph beginning on Page 3, line 14 as follows:

A saw filter of the invention has a piezoelectric substrate, plural numbers of IDT electrodes arranged on a surface of the piezoelectric substrate as well as on a first surface acoustic wave propagation path, reflector electrodes arranged at least at both ends of a first electrode pattern formed including the plural IDT electrodes, one or more IDT electrodes arranged on the surface of the piezoelectric substrate as well as on a second surface acoustic wave propagation path which is different from the first surface acoustic wave propagation path and reflector electrodes arranged at least at both sides of a second electrode pattern formed including the IDT electrode, in which the IDT electrodes on the first surface acoustic wave propagation path are electrically connected in series by connecting wirings and the IDT electrode on the second surface acoustic wave propagation path is connected between the connecting wirings and ~~[[the]]~~ ground, which are arranged between the first electrode pattern and the second electrode pattern.

Please amend the paragraph beginning on Page 4, line 15 as follows:

The SAW filter of the invention can be a structure in which ones of terminals of plural IDT electrodes arranged on the second surface acoustic wave propagation path are connected to ~~[[the]]~~ ground, and the others of terminals are connected to different connecting wirings respectively.

Please amend the paragraph beginning on Page 5, line 4 as follows:

In the SAW filter of the invention, the reflector electrode provided between the IDT electrodes of the first electrode pattern can be connected to [[the]] ground.

Please amend the paragraph beginning on Page 5, line 13 as follows:

A SAW filter of the invention forms surface acoustic wave resonators including a piezoelectric substrate, plural numbers of IDT electrodes arranged on a surface of the piezoelectric substrate as well as on a first surface acoustic wave propagation path, reflector electrodes arranged at least at both ends of a first electrode pattern formed including the plural IDT electrodes, one or more IDT electrodes arranged on a surface of the piezoelectric substrate as well as on a second surface acoustic wave propagation path which is different from the first surface acoustic wave propagation path and reflector electrodes arranged at least at both ends of a second electrode pattern formed including the IDT electrode, in which ones of terminals in the IDT electrodes of the first electrode pattern are respectively connected to [[the]] ground, and the others of terminals are connected to different terminals of the surface acoustic wave resonator.

Please amend the paragraph beginning on Page 13, line 5 as follows:

By only arranging reflector electrode 32, the stray capacitance can be reduced and the deterioration of attenuation in the high-frequency side can be prevented, and when connecting to [[the]] ground, the effect of preventing the deterioration of attenuation further increases, as a result, the characteristic can be further improved.

Please amend the paragraph beginning on Page 13, line 11:

In the embodiment, two IDT electrodes are arranged on the first surface acoustic wave propagation path and one IDT electrode is arranged on the second surface acoustic wave propagation path, however, the invention is not limited to this. For example, three or more IDT electrodes can be provided on the first surface acoustic wave propagation path and two or more IDT electrodes can be provided on the second surface acoustic wave propagation path, and reflector electrodes can be provided between these [[ITD]] IDT electrodes. Further, these reflector electrodes can be connected to [[the]] ground.

Please amend the paragraph beginning on Page 14, line 16 as follows:

In the embodiment, two IDT electrodes are arranged on the first surface acoustic wave propagation path and one IDT electrode is arranged on the second surface acoustic wave propagation path, however, the invention is not limited to this. For example, three or more IDT electrodes can be provided on the first surface acoustic wave propagation path and two or more IDT electrodes can be provided on the second surface acoustic wave propagation path, reflector electrodes can be provided between these [[ITD]] IDT electrodes, and the IDT electrodes on the first surface acoustic wave propagation path can be connected in series by the reflector electrode and the connecting wirings.

Please amend the paragraph beginning on Page 18, line 2 as follows:

Reflector electrodes 58, 59 of the first electrode pattern are not connected to [[the]] ground, however, they can be connected to [[the]] ground as described in the second embodiment.

Please amend the paragraph beginning on Page 18, line 6 as follows:

Fig. 5 is a plan view showing an electrode structure of SAW filter 80 according to a fifth embodiment of the invention. SAW filter 80 of the embodiment differs from SAW filter 10 shown in Fig. 1 in the following point. Namely, in SAW filter 10 of the first embodiment 1, IDT electrodes 12, 13 of the series resonators connected to input terminal 21 and output terminal 22 are provided on a first surface acoustic wave propagation path. On the other hand, in SAW filter 80 of the embodiment, IDT electrodes 81, 82 are provided on the first surface acoustic wave propagation path, ones of terminals of which are connected to input terminal 21 and output terminal 22, and others of terminals of which are connected to ~~[[the]]~~ ground. IDT electrode 81 on the first surface acoustic wave propagation path is connected to reflector electrode 86 on a second surface acoustic wave propagation path by connecting wiring 88, reflector electrode 86 is connected to IDT electrode 85 by connecting wiring 90, and further, IDT electrode 85 on the second surface acoustic wave propagation path is connected to IDT electrode 82 on the first surface acoustic wave propagation path by connecting wiring 89. According to this, two IDT electrodes 81, 82 on the first surface acoustic wave propagation path are electrically connected in series by connecting wirings 88, 89, 90 and reflector electrode 86. IDT electrode 85, reflector electrodes 86, 87 form a resonator on the second surface acoustic wave propagation path, and two IDT electrodes 81, 82 on a first electrode pattern are connected to different terminals of the above resonator.

Please amend the paragraph beginning on Page 26, line 3 as follows:

Fig. 11 is the case in which IDI IDT electrodes 60, 61 on the second surface acoustic wave propagation path are made to be the same phase in SAW filter 100. Fig. 12 is the case in which IDT electrodes 60, 61 are made to be reversed phases in the same SAW filter 100. Further, Fig. 13 is the case in which two ladder-structure resonators are provided on the second surface acoustic wave propagation path. In these cases, phases of two IDT electrodes 51, 52 and phases of two IDT electrodes 53, 54 are reversed, and phases of two IDT electrodes 52, 53 are the same.